



Docket No.: TJ-24816

Examiner: Perez Ramos, V.

Art Unit: 1765

For: **MANUFACTURING METHOD OF SEMICONDUCTOR IC DEVICE**

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1700 MAIL ROOM

REQUEST FOR AFFIDAVIT UNDER MPEP 2144.03

MAILING CERTIFICATE UNDER 37 C.F.R. §1.8(A)

I hereby certify that on this date, the above correspondence is being deposited with the US Postal Service as Express Mail, **EL360245131US**, in an envelope addressed to: Assistant Commissioner For Patents, Washington, DC 20231.

Allen B. Kroger

Date _____

Assistant Commissioner for Patents

Washington, DC 20231

Dear Sir:

The Examiner rejects 1-11 under 35USC 103(a) as unpatentable of Tsuji (U.S. 5,514,625). In her argument, the Examiner admits that “. . . although not disclosed, it is obvious to one skilled in the art that the trenches in Tsuji have sidewalks, as there is no other possible way for a trench to exist known to the Examiner.”.

Applicants challenge the Examiner's assertion, and in the absence of cited art, requested the Examiner to provide an affidavit in accordance with MPEP 2144.03 or withdraw the rejection.

Respectfully submitted,

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